



RECEIVED
FEB 27 2003
TECHNOLOGY CENTER R3700

H.W.
9/ama/Bhe
3/11/03
PATENT

I hereby certify that on the date indicated below, this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to the Commissioner of Patents, Washington, DC 20231.

February 12, 2003

Ayesha S. Wilks

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Trung T. Doan and Gurtej S. Sandhu Attorney Docket No.: 500300.02
Serial No. : 10/054,692 Group Art Unit : 3725
Filed : December 19, 2001 Examiner : William Hong
Title : POLISHING PAD REFURBISHER FOR IN SITU, REAL-TIME CONDITIONING
AND CLEANING OF A POLISHING PAD USED IN CHEMICAL-MECHANICAL
POLISHING OF MICROELECTRONIC SUBSTRATES

Commissioner of Patents
Washington, DC 20231

AMENDMENT

Sir:

Please amend the above-captioned patent application as follows:

In the Specification:

Applicants have attached a new specification incorporating the changes in the Certificate of Correction as requested by the Examiner under MPEP 1411.01. The amendment made to the specification is to column 2, line 29 in which "uniformnly" has been changed to read "uniformly".

02/25/2003 HMARZ11 00000018 10054692

01 FC:1201
02 FC:1202

252.00 OP
414.00 OP